

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Atsushi YAGISHITA, et al. ) Group Art Unit: *Not Yet Assigned*  
)  
Div. of Application No.: 09/609,109 ) Examiner: *Not Yet Assigned*  
)  
Filed: Herewith )  
)  
For: SEMICONDUCTOR DEVICE WITH )  
A DISPOSABLE GATE AND )  
METHOD OF MANUFACTURING )  
THE SAME (AS AMENDED )  
HEREIN )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

Prior to the examination of the above application, please amend this application as follows:

**IN THE TITLE:**

On page 1, please replace the title at lines 2-3 with the following title:

SEMICONDUCTOR DEVICE WITH A DISPOSABLE GATE AND METHOD OF  
MANUFACTURING THE SAME

**REMARKS**

This application is a divisional, under 37 C.F.R. § 1.53(b), of U.S. Patent Application No. 09/609,109, presently allowed. In this Preliminary Amendment, Applicants have amended the title. In accordance with the requirements of 37 C.F.R. § 1.121(c)(1), Applicants provide a

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